

<b>Notice of References Cited</b>	Application/Control No. 10/622,217	Applicant(s)/Patent Under Reexamination ZUBERI, KHAWAR M.	
	Examiner Oleg Survillo	Art Unit 2142	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0252709	12-2004	Fineberg, Samuel A.	370/412
*	B	US-2004/0205379	10-2004	Hilland et al.	714/005
*	C	US-6,067,569	05-2000	Khaki et al.	709/224
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Caitlin Bestler, RE: [rddp] comments on draft-black-rdma-concerns-00.txt., 31 July 2002, IETF, pages 1-3. Retrieved from <a href="http://www1.ietf.org/mail-archive/web/rddp/current/msg00026.html">http://www1.ietf.org/mail-archive/web/rddp/current/msg00026.html</a> on November 28, 2007.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a) )  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.